



Swiss Nanoscience Institute



## Nano Imaging Lab Services for Imaging and Analysis of Nanostructures

## The Nano Imaging Lab

The Nano Imaging Lab (NI Lab) at Basel University's Swiss Nanoscience Institute (SNI) offers a comprehensive service for imaging and analyzing nanostructures. The experienced lab staff conducts an extensive range of microscopic analyses to internal and external clients alike. They offer everything from consulting and preparing samples to imaging.

Depending on the nature of the sample and the client's needs, the NI Lab staff have decades of experience in investigating minute structures. Their varied range of equipment allows them both to precisely map and analyze surfaces, and to display inner structures down to atomic resolution.

The NI Lab trains researchers who regularly require this specialist imaging so that they can work independently with the various devices. The NI Lab also runs several courses each year for biology and nanoscience students, which have consistently been described as especially interesting.

Whether you are working in physics, material science, geology, biology, pharmaceutics, medicine or any other field, the Nano Imaging Lab will be happy to help and provide you with expert assistance whenever required.





The laboratories of the Nano Imaging Lab (at the Pharmacenter and the Physics Department of the University of Basel) supplement each other and offer comprehensive and excellent imaging and analysis services.

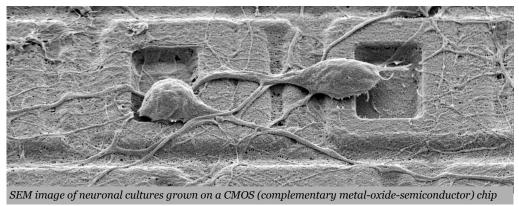




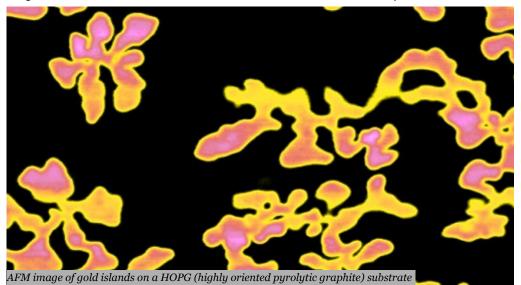
## Technologies in the Nano Imaging Lab

#### Investigating the topology of a sample

The **Scanning Electron Microscope (SEM)** is used to examine sample surfaces with secondary electrons (SE) and to create a topographical image. Back-scattered electrons (BSE) provide information about qualitative material composition. In the **Cryo-SEM**, shock-freezing can be applied to display aqueous samples without drying artifacts.



Atomic Force Microscopy (AFM) can characterize surfaces down to atomic resolution in different media including liquids. In contrast to SEM, a tip scans the surface of a sample. Besides topography, it determines surface properties such as adhesion, elasticity, magnetic or electrostatic field distribution and surface conductivity.

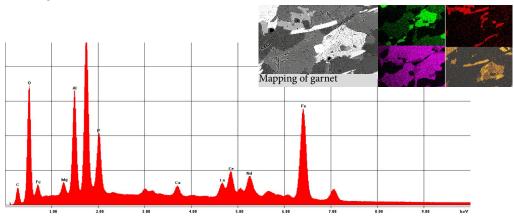


**The Confocal Laser Scanning Microscope (CLSM)** is using a violet laser (408 nm) that scans the surface point by point. This technique records the reflection of the laser light in each point of the surface scan. The surface topography is imaged and analyzed in 3D.



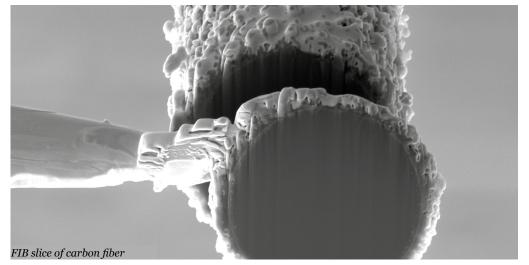
#### Identification and quantification of chemical composition

**Energy-Dispersive X-Ray Spectroscopy (EDX)** is used to identify and quantify elements and compounds. According to a sample image, a region of interest is selected and analyzed. Results are displayed in a single spectrum or as an elemental distribution in an image.



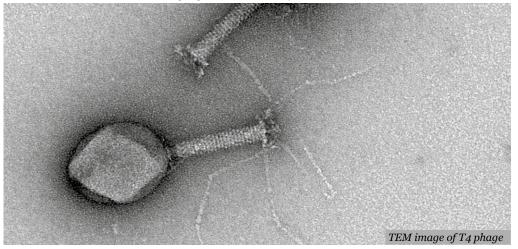
#### **Manipulation of nano-scaled samples**

**Focused Ion Beam (FIB)** technology is used to process nano samples. The ion beam is able to remove and cut material, so that the interior structures of an object can be analyzed. FIB allows, for example, to modify conductor paths and to measure the layer thickness. Fabrication of customized objects can also be performed.



#### Investigating Nanoparticles up to atomic resolution

In **Transmission Electron Microscopy (TEM)** only thin and electron-transparent samples can be analyzed. This provides insights into the inner life of an object. The expertise of the NI Lab is to reveal structures and functions of nanoparticles. A STEM attachment allows enhanced contrast imaging and EDX analysis.



#### From Macroscopy to Nano Imaging

**Correlative Light and Electron Microscopy (CLEM)** uses different imaging technologies applied to the same sample. Starting from a macroscopic image (e.g. light microscopy), a region of interest on the sample is chosen and analyzed with a method of higher resolution (e.g. electron microscopy).

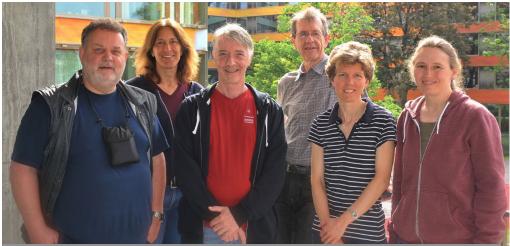
## **The Collaboration Process**

- First contact via the homepage or admin tool (www.nanoimaging1.unibas.ch)
- Discussion of the project
- Preparation of sample material
- Measurement with the appropriate microscopes
- Documentation: Download via web interface

#### Costs

You find a detailed price list at: https://www.nanoscience.ch/en/services-2/nano-imaging-lab/prices/

## Team of the Nano Imaging Lab



arkus Dürrenberger, Susanne Erpel, Daniel Mathys, Christian Schönenberger, Monica Schönenberger, and Eva

## Nano Imaging Lab Equipment

	Method	Microscope
•	FIB/SEM/STEM	FEI Helios Nanolab 650
•	SEM	FEI Nova Nano SEM 230, Hitachi S4800
•	SEM/Cryo-SEM	Philips XL30 ESEM
•	TEM	Philips CM100
•	AFM	Bruker Dimension 3100, JPK NanoWizard <sup>®</sup> 4,
		Nanosurf C3000
•	LSM	Keyence VK-X200
•	Light microscopy	Stereo microscopes
	с II	-

## **Preparation Methods**

- Critical point drying
- Ultra rapid freezing and high vacuum drying
- Mechanical cutting and polishing
- Ar plasma polishing and cutting
- Plasma cleaning
- Negative staining for TEM

# The Nano Imaging Lab is looking forward to fruitful collaborations

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www.nanoimaging.unibas.ch

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